Freeform Search

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Wo-9915933-\$.did.					
Display: 10 Documents in Display Format: - Starting with Number 1					
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DATE: Thursday, October 14, 2004 Printable Copy Create Case

Set Name side by side	Query	Hit Count	Set Name result set
DB =	PGPB, USPT, USOC, EPAB, JPAB, DWPI, TDBD; PLUR=YES; OP=OR		,
<u>L35</u>	wo-9915933-\$.did.	2	L35
<u>L34</u>	L33 not l32	66	
<u>L33</u>	L31 and @ad<20000828	68	L33
<u>L32</u>	L29 and @ad<20000828	2	L32
<u>L31</u>	130 and 19	136	L31
<u>L30</u>	(115 or 120) and ((contact\$4 or ("near" near2 field) or sil or (immersion near5 Lens\$4)) with (expos\$6 or exposing or irradiat\$6 or mask\$1 or photomask\$1 or light))	1815	<u>L30</u>
<u>L29</u>	L28 and 19	16	L29
<u>L28</u>	(115 or 120) same ((contact\$4 or ("near" near2 field) or sil or (immersion near5 Lens\$4)) with (expos\$6 or exposing or irradiat\$6 or mask\$1 or photomask\$1 or light))	326	L28
<u>L27</u>	L26 and @ad<20000828	2	L27
<u>L26</u>	L25 and 19	15	L26
<u>L25</u>	(115 or 120) same ((contact\$4 or ("near" near2 field) or sil or (immersion near5 Lens\$4)) with (exposure or exposed or exposing or irraidat\$6 or	293	<u>L25</u>

	mask\$1 or photomask\$1))		
<u>L24</u>	us-6497996-\$.did. or us-6344367-\$.did.	4	L24
<u>L23</u>	L22 and @ad<20000828	18	L23
<u>L22</u>	L21 and 19	33	L22
<u>L21</u>	L20 same 111	370	L21
<u>L20</u>	L19 near5 (resist\$1 or photoresist\$1)	3488	L20
<u>L19</u>	((two or dual or double) adj3 (level\$4 or layer\$4))	432599	L19
<u>L18</u>	L17 and @ad<20000828	22	L18
<u>L17</u>	L16 and 19	44	L17
<u>L16</u>	L15 same 111	549	L16
<u>L15</u>	L8 near5 (resist\$1 or photoresist\$1)	4981	L15
<u>L14</u>	L13 and @ad<20000828	146	L14
<u>L13</u>	L12 and 19	301	L13
<u>L12</u>	L11 same 18	48604	L12
<u>L11</u>	(grating\$1 or comb or stripe\$4 or lines or periodic)	5956826	L11
<u>L10</u>	L9 same 18	105	L10
<u>L9</u>	((L6 or l4 or l2) near8 (thick or thickness\$4)) with (resist\$1 or photoresist\$1)	4136	<u>L9</u>
<u>L8</u>	(multilevel\$4 or multilayer\$4 or bilayer\$1 or bilevel\$1 or dilevel\$4 or dilayer\$4 or ((bi or di or multi or multiple) adj3 (level\$4 or layer\$4)))	439964	<u>L8</u>
<u>L7</u>	(L6 near8 (thick or thickness\$4)) with 11	19	<u>L7</u>
<u>L6</u>	((0.1 or 0.0\$1) adj3 (micron\$1 or mum or .mu\$4))	67694	<u>L6</u>
<u>L5</u>	(L4 near8 (thick or thickness\$4)) with 11	238	L5
<u>L4</u>	((1000 or 9\$2 or 8\$2 or 7\$2 or 6\$2 or 5\$2 or 4\$2) adj3 (angstrom or ang or .ang\$4))	111892	<u>L4</u>
<u>L3</u>	(L2 near8 (thick or thickness\$4)) with 11	292	<u>L3</u>
<u>L2</u>	((100 or 9\$1 or 8\$1 or 7\$1 or 6\$1 or 5\$1 or 4\$1) adj3 nm)	147302	L2
<u>L1</u>	((upper or top or topmost or second or first) near5 (resist\$1 or photoresist\$1))	72577	<u>L1</u>

END OF SEARCH HISTORY